



PATENT

Case Docket No. ASMINT.002C3

Date: August 24, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Granneman et al.
Appl. No. : 10/603,515
Filed : June 24, 2003
For : METHOD AND APPARATUS
FOR SUPPORTING A
SEMICONDUCTOR WAFER
DURING PROCESSING
Group Art Unit : 1763
Class/Sub-Class : 118-728000
Examiner : Parviz Hassanzadeh

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

August 24, 2004

(Date)

Adeel S. Akhtar
Adeel S. Akhtar, Reg. No. 41,394

TRANSMITTAL LETTER

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing is the Issue Fee for the above-identified application:

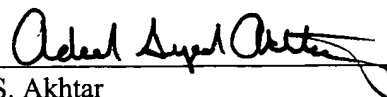
- (X) Form PTOL-85.
- (X) A check in the amount of \$1,660 to cover the issue fee, publication fee, and advanced order of copies is enclosed.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE in 2 pages.

PATENT

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Date: August 24, 2004

(X) Return prepaid postcard.



Adeel S. Akhtar

Registration No. 41,394

Attorney of Record

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CERTIFICATE OF MAILING

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Adeel S. Akhtar

Adeel S. Akhtar, Reg. No. 41,394

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE**Mail Stop ISSUE FEE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Applicants appreciate the finding of the pending claims to be allowable. In the Reasons for Allowance accompanying the Notice of Allowability, the Examiner quoted Claim 1.

Applicants note that not all claims recite all limitations of Claim 1. For example, not all claims recite that "the first and the second reactor blocks are configured to surround a substrate with gas cushions to suspend the substrate between the first and the second reactor blocks upon assembly of the first and the second reactor blocks in the reactor and upon retention of the substrate therebetween." Thus, Applicants assume that, pursuant to M.P.E.P. § 1302.14, the Examiner has stated some, but not all, of the reasons for allowance of the claims and that, as a result, the statements discussed above do not necessarily relate to or completely set out the

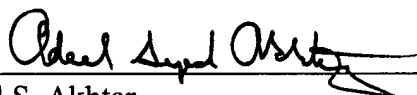
Appl. No. : 10/603,515
Filed. : June 24, 2003

- reasons for allowance of each and every claim.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: August 24, 2004

By: 
Adeel S. Akhtar
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